

**FORM PTO-1449  
INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT(S)**

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Inventors : Masahiko SAITO, et al.  
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Examiner : Kenneth Tang



**U.S. PATENT DOCUMENTS**

Examiner Initial	Patent Number	Patent Date	Name	Class/ Subclass	Filing Date
KF	5,826,081	10/20/98	ZOLNOWSKY	395/673	

**FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class/ Subclass	Translation Yes No
KF	05-108380	04/30/93	Japan		ABS.
KF	04-367037	12/18/92	Japan		ABS.

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
KF	1. The Survey of HITACHI Technology, HITACHI HYOURON, Japan, HITACHI HYOURON CORPORATION, Jan. 1999, Vol. 81, number 1, pages 27-29.
KF	2. Office Action (Rejection Reasons Notification) issued in the Japanese Priority Application No. heisei 11-041032, 27 April 2004 & translation thereof.

EXAMINER

DATE CONSIDERED

Kenneth Tang

10/12/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.